

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Shinji Omori et al.

Application 10/534,917

Group Art Unit: 2892

Filed: September 26, 2005

Confirmation No. 1773

Customer No.: 26263

Examiner: Phuc T. Dang

For: EXPOSURE DEVICE, EXPOSURE METHOD, AND SEMICONDUCTOR
DEVICE MANUFACTURING METHOD

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT "A"

Sir:

This amendment is filed in response to the non-final Office Action mailed April 8, 2008.
Please reconsider the application in view of the amendments and remarks presented herein.